

**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:	Confirmation No.: 5377
Makiko KITAZOE, et al	Art Unit: 1792
Application No.: 10/591,905	Examiner: Keath T. CHEN
Filed: November 6, 2006	Attorney Docket No.: 029567-00010
For: SELF-CLEANING CATALYTIC CHEMICAL VAPOR DEPOSITION APPARATUS AND CLEANING METHOD THEREOF	

AMENDMENT UNDER 37 C.F.R. §1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 20, 2008

Sir:

In reply to the June 19, 2008, Office Action, the period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims, being on page 2;
and

Remarks begin on page 7.